

ALD 2015 - Conference on Atomic Layer Deposition

Veranstaltung - ALD 2015 - Conference on Atomic Layer Deposition

Titel	ALD 2015 - Conference on Atomic Layer Deposition
Wann	So, 28. Juni 2015 - Mi, 1. Juli 2015

Beschreibung

ALD 2015 - Conference on Atomic Layer Deposition

The AVS Topical Conference on Atomic Layer Deposition (ALD 2015) will be dedicated to the science and technology of atomic layer controlled deposition of thin films.

Please find more information by following link:

<http://www2.avs.org/conferences/ALD/2015/index.html>

Lokalität - Portland

Standort	Portland
Ortsname	Portland
Bundesland	Oregon
Land	US